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Sheet 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of 2

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Application Number	10/510151			
Filing Date	May 30, 2006			
First Named Inventor	Kia Silverbrook			
Art Unit	2853			
Examiner Name	Julian D Huffman			
Attorney Docket Number	YU181NPUS			

U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number-Kind Code ^{2 (if known)}			rigures Appear	
		US 2002/024569 A1	Feb 28 2002			
		US 4370663 A	Jan 25 1983	Marham et al		
		US 4475113 A	Oct 2 1984	Lee et al		

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		JP 03-065348 A	Mar 20 1991	Matsushita Elec Ind	Co Ltd	√

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	ATAKA, MANABU et al, "Fabrication and Operation of Polymide Bimorph Actuators for Ciliary Motion System". Journal of Microelectromechanical Systems, US, IEEE Inc. New York, Vol. 2, no. 4, 1 December 1993, pp 146-150, XP000443412, ISSN: 1057-7157.	1
	NOWOROLSKI J M ET AL: "Process for in-plane and out-of-plane single-crystal-silicon thermal microactuators" Sensors And Actuators A, Ch. Elsevier Sequoia S.A., Lausane, Vol 55, no. 1, 15 July 1996 (1996-07-15), Pages 65-69, XP004077979	1
	YAMAGATA, YUTAKA et al, "A Micro Mobile Mechanism Using Thermal Expansion and its Theoretical Analysis". Proceedings of the workshop on micro electro mechanical systems (MEMS), US, New York, IEEE, Vol. Workshop 7, 25 January 1994, pp 142-147, XP000528408, ISBN: 0-7803-1834-X.	1
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